



Pulse-to-pulse Beam Modulation for KEKB and PF Injections and Energy Management at KEK 8GeV Linac

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KEKI

Electron Accelerator Complex

Linac clients ***KEKB** Advanced Ring for oulse X-ravs) 8-GeV e- 1nC x2 3.5-GeV e+ 1nC x2 (with 10nC primary e-) PF 2.5-GeV e– 0.1nC (Photon Factory) PF-AR 3-GeV e– 0.2nC At first simultaneous top-up injections to three rings at KEKB and PF Switching beams at 50Hz For stable operation and higher quality exp. results

IINAC





Operation groups at KEKB and linac

- Overlapped groups
- Many attend commissioning group from eq. groups
- Daily KCG meeting
- Weekly LCG meeting



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- Luminosity degradation on beam studies at PF and PF/AR
- Future SuperKEKB injections with shorter lifetime
- Sensitive luminosity tuning with Crab cavities
- PF top-up injection for higher quality experiments
 - CERN/PS switches beams every 1.2s (PPM)
 - **SLAC/SLC switched beams at 180 Hz**
 - KEK Linac had switched beams 360 times a day in 2008 (just before simultaneous injection)
 - 10~120seconds per switching

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Requirements

Maximum beam rate of 50Hz x 2bunches should be kept

Most pulsed power supplies were designed to operate at constant rate (a restriction)

Most linac magnets were not pulsed (except positron focusing coil)

Thus, it took much time for mag-field standardization

Approx. 1000 devices in linac

*600 active devices (gun, RF, magnets, etc), 100 passive devices (BPM, WS, etc), and static devices

20ms beam switching became the solution



Hardware and Operation Improvements

- Separate BT for PF (2005)
- Pulsed bending magnet for PF (2007)
- PF beam from common gun (A1) (2007)
- Beam charge safety interlock (2007)
- Event-based fast control system (2008)
- Pulsed steering magnets (2008)
- Electron bypass hole at positron target (2008)
- Interface between ring-linac RF (2008)
- Multi-energy linac optics (2008)
- Simultaneous injections (Apr.2009)

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Simultaneous Injection and Energy Management

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Power Management

Power management at each power source

- In the second second
- In order to maximize the power
- But not to increase the trip rate
 - ☐ Interlock at a reflection level VSWR of 1.4
 - If a trip rate is higher, the voltage is lowered
 - Surveyed statistically every week

Some sources will be stand-by state

- As backups, if the energy is enough
 - KEKB e+ has several stand-by, KEKB e- has typically one

Energy conversion

Energy gain = constant x sqrt(power)





Cavity and Klystron Database

Updated on replacements of klystrons and cavities Converted into control database

sector	unit	No	新/旧	typ	d(WG)	α	М	Es-Power	c2	c1	<i>c0</i>	Es	Power	Gain	Gain	Eave	stand	Total
					m			データ更新				kV	MW	MeV	MeV	MV/m	by	MeV
A	1	0	旧	-	-	-	1.00	04.08.30	-0.04728	6.58617	-138.81662	40.0	49.0	19.0	19	_	1	19
		1	新	Α	14.33	0.94400	1.00	04.08.30	-0.04728	6.58617	-138.81662	40.0	49.0	24.0	48	12.7		43
		2	新	Α	14.33	0.94400	"	*	"	"	"	"	"	24.0	*	12.7		67
	8	1	н	D	13.28	0.93868	1.85	98.10.01	0.00000	1.93650	-38.76900	41.5	41.6	43.5	171	23.0	1	3004
		2	IH	D	13.35	0.93834		*	0.00000					43.5	*	23.0		3047
		3	IH	D	13.28	0.93868		*	0.00000					43.5	*	23.0		3091
		4	IЦ	А	13.35	0.93834		^	0.00000					40.8	^	21.6		3131
	1	1	IН	Е	13.28	0.93868	1.85	_	0.00000	2.07020	-46.72400	43.0	42.3	44.8	179	23.7	1	3176
		2	IH	E	13.35	0.93834		*	0.00000		"			44.8	*	23.7		3221
		3	IН	E	13.28	0.93868		*	0.00000		"			44.8	*	23.7		3266
		4	IН	E	13.35	0.93834		*	0.00000					44.8	*	23.7		3310
	2	1	IН	С	13.28	0.93868	1.85	03.09.16	0	2.47830	-65.41700	41.5	37.4	40.4	162	21.4	1	3351
		2	IН	С	13.35	0.93834		*	0.00000				"	40.4	*	21.4		3391
		3	IН	С	13.28	0.93868		*	0.00000				"	40.4	*	21.4		3432
		4	IH	С	13.35	0.93834		*	0.00000					40.4	*	21.4		3472
	3	1	IH	D	13.28	0.93868	1.85	98.11.15	0.00000	2.32860	-55.54400	42.5	43.4	44.4	178	23.5	1	3516
		2	IН	D	13.35	0.93834		*	0.00000					44.4	*	23.5		3561
		3	IН	D	13.28	0.93868		*	0.00000					44.4	*	23.5		3605
		4	IH	D	13.35	0.93834			0.00000					44.4	*	23.5		3650
	4	1	IН	С	13.28	0.93868	1.85	06.08.30	-0.12241	12.00654	-248.55271	43.5	42.1	42.8	171	22.7	1	3693
		2	IH	С	13.35	0.93834		*	0.00000					42.8	*	22.7		3735
		3	IH	С	13.28	0.93868		•	0.00000					42.8	*	22.7		3778
		4	IH	С	13.35	0.93834		•	0.00000					42.8	*	22.7	п	3821
	5	1	IH	Е	13.28	0.93868	1.85	01.04.22	0	2.33330	-53.62000	44.0	49.0	48.2	191	25.5	1	3869
		2	IH	E	13.35	0.93834			0.00000		"			48.2	*	25.5		3918

Simultaneous Injection and Energy Management

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Crest Phase Calibration

Each power source with slow phase shifter

- Energy measurement scanning the phase shifter
 - Primitive but reliable, while there were several methods
 - Chicken and egg issue exists on bootstrap
 - If no beam at the end, no measurement possible
- Every several month at least after the long shutdown
 - X Automated measurement takes ~2hours for 60 sources
- Result is saved as a reference to other software If the voltage was changed, nominal crest change is applied (1kV => ~8degree) (to be measured later)



Typical Automated Phase Calibration







Energy Profile

8 driver klystrons with fast phase shifters

- Each manage ~8 high power klystrons
- Define the overall energy profile
- With Small phase angle (from the crest)
 - Energy spread compensation depending on beam charge

4 klystrons with fast phase shifters

- Forming two energy-knobs to adjust the energies
 - Before the arc and at the end of the linac
- Not to enlarge the energy spread
 - Two klystrons are grouped

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Two-bunch Energy Equalization

Two bunch in a pulse

- Energy compensation
 - Depending on beam charge

Fast timing adjustment

- Automated measurement
- Same procedure
 - **X** As crest phase measurement
 - **With ns timing as a variable**







Beam Optics Matching

Based on energy profile, fudge factors, etc.

Wire scanner measurements
Every several days
Somewhat affected by background noise
Matching by a push button





Quad Fudge Factor

Twiss parameter measurement with wire scanners

Fudge factor determination, last done in 2008

Orbit Observation
 with Single kicks
 Several iterations

One wiring error was found







Fast Controls for Three Energy Profiles 8 driver klystrons with fast phase shifters for overall energy profile and energy spread comp. Acceleration/stand-by for 60 klystrons for rough energy adjustment, for back-up 4 energy knob klystrons for final energy adjustment SLED timing of LLRF at 8 driver klystrons for two-bunch in a pulse energy equalization

Parameter change every 20ms is necessary





Simultaneous Injection and Fast Controls





Fast Controls

~100 parameter switching within 20ms *Keep most of magnet fields with compatible optics Control IIrf to change energy

Pulsed magnet triggers and delays
Delays to keep the constant rate for certain power-supplies
LLRF phases and delays
Gun voltage and fine delay
Interface to bucket selection, etc

Ethernet-based controls are not reliable enough
 FPGA and fiber-optic RocketIO might be the way ?





Many accelerator system require timing signals and accompanying information (event)

- Several primitive facilities are combined and used at KEKB and Linac
 - **Fast Timing signals are provided with delay module TD4/TD4V**
 - Need timing trigger and rf clock
 - (Slow) Events are provided in another facility
 - Combining Hardware and Software
- Event/Timing Systems which distribute the both timing and event are developed at Argonne/SLS/Diamond, and are employed at many institutes (Event Generator/Receiver)
 - Fast Timing, rf clock, Hardware event, Software Interrupt, can be handled in one combined system with a single fiber cable
 - Especially in EPICS, event can be connected EPICS Event directly, so record/database programming is possible



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Timing System



Old Timing Station





New Event Receiver Station with 16 outputs







Event System

Simultaneous Injection to KEKB-HER, KEKB-LER, and PF 2.5GeV to 8GeV, 0.1nC to 10nC Stable stored beam current at three rings Should improve collision tuning with Crab cavities Should improve the quality of experimental data at PF Fast switching of many device parameters **♦ In 20ms / 50Hz** Should be reliable because beam power is much different MRF Series 230 Event Generator / Receiver **VxWorks 5.5.1, MVME5500** (Originally with RTEMS but...) **Timing precision less than 10ps is sufficient** (TD4 provides 3ps) Multi-mode fiber, and single-mode fiber for longer distance



Event System Configuration



Event Generator

KL_51/52

Cont-5

SB 5

SB 4

Event Receivers

Cont-4

Cont-3

- VME64x and VxWorks v5.5.1
- EPICS R3.14.9 with DevSup v2.4.1
- 17 event receivers up to now

Central

SB B

Cont-ABC

SB C

KL B5/B6

ARC



More than hundred 50Hz-Analog/Timing data



Timing precision is < 10ps.
 < 1ps with external module.



e⁺ BT (KEKB: 3.5GeV, 2nC)

e⁻ BT (KEKB: 8GeV, 2nC,

PFAR: 3.0GeV. 0.1nC)

Simultaneous Injection and Energy Management

SB

SB

e⁻∕Gun

/Target

Cont-2

 e^+

Cont-1

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Synchronization Scheme











Beam Mode Pattern Generators

Pattern panel arbitrates requests

- From downstream rings with priorities, or human operators
- There are several pattern rules due to pulse device features and limitations
- Pattern arbitrator software was written in scripting languages to meet daily changes during the commissioning stage

Remote controlled automatic pattern arbitrator

InjPattern-multi										
File	ile InjPattern-multi									
Priority	9/04/28 10:51:43									
PF-A1 e-	KEKB e-	KEKB e+	PF(CT) e-	PF-A1 e-	AR e-					
KEKB e+ KEKB e-	25 Hz 😑	0.000 Hz 😑	0.000 Hz 🖃	0.5 Hz 😑	0.000 Hz 😑					
AR e- PF(CT) e-	Set	Set	Set	Set	Set					
KEKB e- Study	12.500 Hz	25.000 Hz	0.000 Hz	0.500 Hz	0.000 Hz					
KEKB e+ Study	12.500 Hz	25.000 Hz	0.000 Hz	0.500 Hz	0.000 Hz					
PF(CT) e- Study	KEKB e- Study	KEKB e+ Study	PF(CT) e- Study	AR e- Study						
PF-A1 e- Study AR e- Study	0.000 Hz 😑	0.000 Hz 😑	0.000 Hz 😑	0.000 Hz 😑	0.000 Hz 😑					
5	Set	Set	Set	Set	Set					
1 100	0.000 Hz	0.000 Hz	0.000 Hz	0.000 Hz	0.000 Hz					
Un Down	0.000 Hz	0.000 Hz	0.000 Hz	0.000 Hz	0.000 Hz					
Down	Read ALL Se	et ALL "O Hz"			Set ALL					
Ready.										

◆ Typical operation in 2009.
 ¤~25Hz for KEKB LER
 ¤~12.5Hz for KEKB HER
 ¤~0.5Hz for PF

Manual pattern generator







Parameters

Parameters switching via Event system

- LLRF phase/timing : 14x4
- ♦ HP RF timing : ~60
- Gun voltages, picosecond delay : 4
- Pulsed magnets/solenoid : 14
- **Injection phase : 2**
- Bucket selection : 2
- **♦BPM** : ~100x3
- Basically sufficient for fast beam mode switching
- More parameters comming
- Integrity monitors
- Improved slow beam feedback, fast feedback, etc.

Linac Event System

Satisfies the requirements

- Event rate : 114.24MHz (bit rate : ~2.3GHz)
- Fiducial rate : 50Hz
- Timing jitter (Short term) : ~8ps
- ♦No. of defined events : ~50
- No. of receiver stations : 17
- No. of Fast parameters : ~130

CPU stopped 4 times since Sep.2008 for 18 stations











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0.0

Vacuum : 2.1E-8

I*τ :

∫ Idt:

BL03

BL 07

 $_{15}$

[hours]



[A•min]

[Pa]

7000.0 [A·h]

BL04

BI 08

BL12

.16

Beam Current

Time:

BL05

BL09

BL13

Lifetime :

BL01 CLOSE

Beam Current: 449.9 [mA]

0.0

BL 02

BI 06

BI 10

14

Beam currents are kept within KEKB 1mA (~0.05%) PF 0.05mA (~0.01%)









Summary

Energy management of KEKB linac was successfully applied to simultaneous injection

- Covers 2.5GeV 8GeV, 0.1nC 10nC
- Beam optics diagnosis down to ~1%

Simultaneous injection to HER/LER/PF was successful

- Development and installation for various kind of hardware
- Another layer of controls based on a fast event system
 - Pulse-to-pulse reprogramming of event system

Simultaneous injection will be the base for SuperKEKB as well



Thank you